Special Issue

Micro-Opto-Electro-Mechanical Systems (MOEMS)

Message from the Guest Editor

The Special Issue of the journal *Applied Sciences* called "Micro-Opto-Electro-Mechanical Systems (MOEMS)" aims to cover recent advances in the development of MOEMS devices and systems from all disciplines, including fabrication techniques, novel devices and components, advanced systems, and the latest applications.

Guest Editor

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Message from the Editor-in-Chief

As the world of science becomes ever more specialized, researchers may lose themselves in the deep forest of the ever increasing number of subfields being created. This open access journal Applied Sciences has been started to link these subfields, so researchers can cut through the forest and see the surrounding, or quite distant fields and subfields to help develop his/her own research even further with the aid of this multidimensional network.

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